



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Li-Wen Chen

Appl. No.: 10/764,644

Confirm. No.: 9092

Filed: January 26, 2004

Title: METHOD FOR DYNAMIC PROFILING

PATENT APPLICATION

Art Unit: 2175

Examiner: PARDO, Thuy N

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Art Unit 2175, Alexandria, VA 22313-1450, on February 28, 2005.

(Signature)

Paul A. Durdik, Reg. No.: 37,819

Signature Date: February 28, 2005

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Art Unit 2175

Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 30, 2004, please amend the above-identified application as follows:

Remarks begin on page 2 of this paper.

Appendix A: Terminal Disclaimer starts on page 4 of this paper.